

Coherent Manipulation of Thermal Transport by Tunable Electron-Photon and Electron-Phonon Interaction

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We propose a system where coherent thermal transport between two reservoirs in non-galvanic contact is modulated by independently tuning the electron-photon and the electron-phonon coupling. The scheme is based on two gate-controlled electrodes capacitively coupled through a dc-SQUID as intermediate phase-tunable resonator. Thereby the electron-photon interaction is modulated by controlling the flux threading the dc-SQUID and the impedance of the two reservoirs, while the electron-phonon coupling is tuned by controlling the charge carrier concentration in the electrodes. To quantitatively evaluate the behavior of the system we propose to exploit graphene reservoirs. In this case, the scheme can work at temperatures reaching 1 K, with unprecedented temperature modulations as large as 245 mK, transmittance up to 99% and energy conversion efficiency up to 50%. Finally, the accuracy of heat transport control allows us to use this system as an experimental tool to determine the electron-phonon coupling in two dimensional electronic systems (2DES).

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I. INTRODUCTION

Control and manipulation of thermal currents in solid-state structures is of particular interest especially at the nanoscale where heat strongly affects the physical properties of the systems. In this direction, coherent caloritronics [1–3], which takes advantage of phase-coherent mastering the heat current in solid-state nanostructures, represents a crucial breakthrough in several fields of science at cryogenic temperatures such as quantum computing [4], ultrasensitive radiation detectors [5] and electron cooling [6, 7]. Although phase coherence plays a fundamental role in the functionalities of several nano-electronic devices, the impact of coherence in caloritronics is far to be completely understood. Despite it is smaller than galvanic thermal transport [8], electron-photon mediated heat transfer [1, 9–11] provides the possibility of contactless heating or cooling bodies in non-galvanic contact allowing to investigate low energy physics in small quantum devices, and put the basis of novel-concept logic elements. These approaches assume that at low temperatures the phonon modes become effectively frozen [1, 12] and the energy losses through electron-phonon coupling are minimized.

Yet, the possibility of in-situ tuning the impedance matching and the electron-phonon coupling in such systems can pave the way to new device concepts, unexplored physical effects and novel quantum-state engineering. Here, we propose a device able to fully control the coherent heat transport between two bodies in non-galvanic contact by modulating their electron-photon interaction and their electron-phonon coupling.

II. THERMAL MODEL

The system we study consists of a source S and a drain D electron reservoirs (see Fig. 1-a) interacting through an intermediate coupling circuit (CC). The lattice phonons residing in every element of the structure are assumed to be thermalized with the substrate phonons at bath temperature T_{bath} , because of the vanishing Kapitza resistance between thin conductors and the substrate at low temperatures [2, 13]. The heat losses are exclusively due to the electron-phonon interaction. In the steady state, a power P_{in} injected into the source electrode originates a heat flow described by the following system of energy balance equations:

$$\begin{cases} P_{in} = P_{e-ph_S} + P_{RS-RD} \\ P_{RS-RD} = P_{e-ph_D}. \end{cases} \quad (1)$$

Above P_{e-ph_S} and P_{e-ph_D} are the power losses due to electron-phonon coupling in S and D , respectively, and P_{RS-RD} is the electron-photon mediated power transfer between the two reservoirs in non-galvanic contact. As a consequence, for a non-zero P_{RS-RD} the temperatures of the source T_S and drain T_D electrodes differ from the phonon temperature T_{bath} and follow $T_S \geq T_D \geq T_{bath}$ (in the case of positive P_{in}).

Here, we focus initially our attention on P_{RS-RD} . The heat transport between two remote bodies mediated by the electron-photon interaction has been studied within a nonequilibrium Green's function formalism [9] or a circuitual approach [10]. For simplicity, our analysis is based on the circuitual approach, since the two methods give equivalent results [10]. A thermal excitation generates a fluctuating noise current in each element of the system. The thermal current between S and D can be calculated as the difference between the power emitted from the drain and the source reservoirs due to the electromag-

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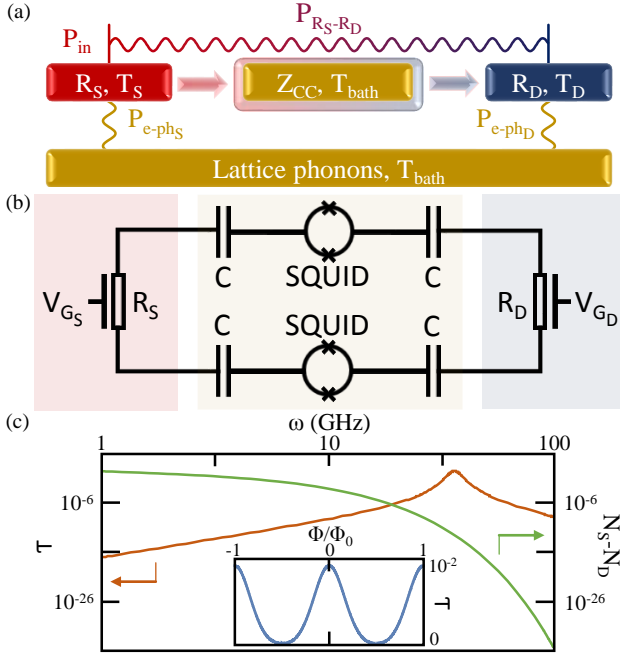


FIG. 1: (a) Thermal model of the system: the red and blue rectangles represent the source (S) and drain (D) electrode characterized by different impedances (R_S and R_D) and temperatures (T_S and T_D). The gold rectangle depicts the coupling circuit CC of impedance Z_{CC} at temperature T_{bath} . The wavy lines portray the heat exchange involved: P_{e-phS} and P_{e-phD} represent the power losses due to electron-phonon coupling in the reservoirs, while P_{RS-RD} is power transmitted from S to D due to the electron-photon interaction mediated by CC . (b) Equivalent electric circuit of the system: S and D electrodes are represented as resistors R_S and R_D controlled by the gate voltages V_{G_S} and V_{G_D} , respectively. The four capacitors C and the two SQUIDs composing the CC are shown. (c) Typical transfer function $\mathcal{T}(\omega)$ (orange line) and difference between bosonic functions for the photons in S and D (green line) as a function of frequency for a flux $\Phi = 0$. Inset: $\mathcal{T}(\omega = 50 \text{ GHz})$ as a function of Φ . The used parameters are: $C_{SQUID} = 29 \text{ fF}$, $L_0 = 1 \text{ nH}$, $C = 750 \text{ fF}$ and $R_S = R_D = 50 \Omega$.

netic noise, and it can be expressed as:

$$P_{RS-RD} = \int_0^\infty \frac{d\omega}{2\pi} \hbar\omega \mathcal{T}(\omega) [N_D(\omega) - N_S(\omega)], \quad (2)$$

where $\mathcal{T}(\omega)$ is the photonic transfer function of the system, while N_S and N_D are the Bose-Einstein distributions of the source and drain photon reservoirs, respectively. The frequency-dependent transfer function is defined as [10]:

$$\begin{aligned} \mathcal{T}(\omega) &= \frac{4\Re[Z_S(\omega)]\Re[Z_D(\omega)]}{|Z_{TOT}(\omega)|^2} = \\ &= \frac{4R_S R_D}{|R_S + Z_{CC}(\omega) + R_D|^2}, \end{aligned} \quad (3)$$

where Z_S , Z_D and $Z_{CC}(\omega)$ are the frequency-dependent

impedances of S , D and coupling circuit, respectively. The impedance of source and drain are assumed to be completely resistive ($Z_i = R_i$ with $i = S, D$). In order to phase coherently modulate the electron-photon interaction, it is necessary to design an appropriate electronic circuit with a tunable Z_{CC} . A typical intermediate quantum circuit is represented by a flux-controlled dc-SQUID (superconducting quantum interference device)[1, 9, 10, 14], which is modeled as a LC resonator with a magnetic flux-dependent inductance $L_{SQUID}(\Phi) = L_0/|\cos(\pi\Phi/\Phi_0)|$ [1, 8], where $L_0 \propto 1/I_C$ is the Josephson inductance arising from the device critical current I_C , Φ is the flux threading the loop and $\Phi_0 = 2.067 \times 10^{-15} \text{ Wb}$ is the flux quantum. Therefore, the SQUID acts as a phase-dependent thermal modulator.

The implementation that we have chosen in order to ensure phase-coherent heat modulation in non-galvanic contacts is depicted in Fig. 1-b, where a dc-SQUID is capacitively-coupled with the electron reservoirs. Then the total series impedance of the coupling circuit is $Z_{CC} = 2Z_C + Z_{SQUID}$, where $Z_C = 1/i\omega C$ and $Z_{SQUID} = i2\omega L_{SQUID}/[1 - (\omega\sqrt{L_{SQUID}C_{SQUID}})^2]$ [1] are the impedances of the capacitor and the dc-SQUID, respectively. Contrary to the narrow-band pass filter characteristic of an inductive coupling [9, 10], the broad-band pass filter behavior of capacitive coupling ensures the maximum power transfer across the device, because the term $[N_D(\omega) - N_S(\omega)]$ of Eq. (2) shows the maximum value at low photon frequency (see Fig. 1-c). Furthermore, thermal transport across the system P_{RS-RD} is maximized by increasing the mutual inductance M between the reservoirs and the coupling circuit [9, 10], but the modulation of P_{RS-RD} is maximum when the geometrical inductance of CC is low and the Josephson inductance of the SQUID dominates. The impossibility to simultaneously fulfill these two conditions makes inductive coupling unusable in real caloritronic devices. Oppositely, large capacitances can be easily realized in experiments and do not require any constrain in the SQUID geometry. The reactive impedances due to the presence of the gates coupled to the source and drain electrodes are much smaller than the coupling capacitances and, therefore, they can be neglected in the circuit model of the device.

Equation (3) clearly shows that the transfer function $\mathcal{T}(\omega)$ also depends on the values of the source and drain impedances, and it is maximized in the case of a matched circuit ($Z_S = Z_D$). Therefore, the electron-photon interaction can also be modulated by controlling the value of R_S and R_D . We propose the use of a two dimensional electron system (2DES) as material implementing the S and D electrodes. By employing two gates (V_{G_S} and V_{G_D} in Fig. 1-b) it is possible to independently control the charge carrier concentration n of the two reservoirs. As a consequence, the modulation of their resistance ($R_S, R_D \propto 1/n$) is reflected in a change of P_{RS-RD}

and thereby in thermal transport across the system. The parasitic capacitance associated to the presence of the gate electrodes is negligible small compared to the coupling capacitance C , therefore the impedance of S and D can be still considered fully resistive ($Z_i = R_i$ with $i = S, D$) and Eq. (3) holds. This architecture represents a perfect platform to study the impact of impedance matching on the thermal properties of solid-state nanostructures. For instance, a variable impedance source electrode can be beneficial to control the temperature of a quantum device (as an example a quantum dot) without interfering with the behavior of the latter through contactless heat transport.

We now turn to the analysis of P_{e-ph} . In the following we impose a constant T_S , thereby we will consider only the impact of P_{e-ph_D} on thermal transport. The changes in the electron-phonon coupling in the source electrodes P_{e-ph_D} has impact only on the power that is necessary to provide to the system in order to reach the desired value of T_S . Equation (1) shows that the thermal efficiency of the system strongly depends on the electron-phonon coupling of the source and drain electrodes. At temperatures lower than the Debye temperature, the power is dissipated to the lattice only through the acoustic phonons. In a clean metal the electron-phonon dissipation takes the form $P_{e-ph} = \Sigma V(T_e^5 - T_{bath}^5)$, where Σ is the electron-phonon coupling constant and V is the volume [14]. The coupling constant is peculiar for every material and it is defined as $\Sigma = 12\zeta(5)k_B^5|D_P|^2/\pi\hbar^5v_S^3$ where $\zeta(5) \approx 1.0369$, D_P is the deformation potential and v_S is the speed of sound in the material. In the dirty limit (diffusive regime) P_{e-ph} scales with T^4 or T^6 depending on the nature of disorder [15, 16]. In conventional caloritronic devices the reservoirs are usually made of metals, and Σ is fixed by the choice of material. As mentioned above, we propose to use gated 2DESs as source and drain electrodes. In two dimensional electronic systems the electron phonon coupling constant depends on the charge carrier concentration [17, 18]. Therefore, our system allows to in-situ modulate Σ and, therefore, the temperature of the drain electrode T_D by tuning the gate voltage applied to the reservoirs. This new knob increases the versatility of caloritronic devices paving the way to novel applications.

In order to quantify the impact of $P_{R_S-R_D}$ and P_{e-ph_D} on the modulation of the heat transfer we suppose to exploit S and D electrodes made of graphene. The thermal properties of graphene have been extensively studied [19–22], but it has never been used in coherent caloritronic systems so far. Its small volume, versatility and the possibility of producing samples of different quality make graphene the prototype candidate of tunable material for caloritronic applications. The power exchanged between electrons and phonons in graphene depends on its charge carrier concentration, which can be controlled through gate electrodes, and mobility [23].

In the clean limit (i.e., implying the mean free path $\ell \geq 1\mu m$) it takes the form [24]:

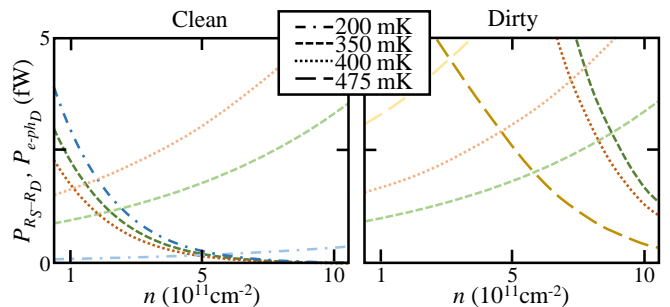


FIG. 2: $P_{R_S-R_D}$ at $\Phi = 0$ (dark) and P_{e-ph_D} (light) as a function of $n = n_S = n_D$ for different values of T_S in the limit of clean (left) and dirty graphene (right).

$$P_{e-ph_{clean}} = A\Sigma_{clean}(T_e^4 - T_{bath}^4), \quad (4)$$

where A is the area of the graphene sheet, T_e is the electronic temperature and $\Sigma_{clean} = (\pi^2 D_P^2 |E_F| k_B^4)/(15\rho_M \hbar^5 v_F^3 v_S^3)$ is the electron-phonon coupling constant. In the latter, $v_F = 10^6$ m/s is the Fermi velocity, D_P is the deformation potential, $E_F = \hbar v_F \sqrt{\pi n}$ is the Fermi energy, ρ_M is the mass density and $v_S = 2 \times 10^4$ m/s is the speed of sound in graphene. The temperature of lattice phonons of graphene is assumed to be the same of the substrate T_{bath} , because the vanishing Kapitza resistance ensures full thermalization at low temperatures [25]. In the dirty limit ($\ell \leq 100$ nm), the power losses due to electron-phonon coupling have a T^3 dependence and are expressed [26] as follows:

$$P_{e-ph_{dirty}} = A\Sigma_{dirty}(T_e^3 - T_{bath}^3), \quad (5)$$

where the electron-phonon coupling constant takes the form $\Sigma_{dirty} = (1.2D_P^2 |E_F| k_B^3)/(\pi^2 \rho_M \hbar^4 v_F^3 v_S^2 \ell)$.

III. RESULTS AND DISCUSSION

In order to solve the energy balance system [Eq. (1)] and quantitatively analyze the behavior of the efficiency of the system, we use the following values for the physical quantities: $T_{bath} = 10$ mK, $C_{SQUID} = 29$ fF, $L_0 = 1$ nH, $C = 750$ fF and $A = 12.5 \mu m^2$. Since the transfer function is maximized for a matched circuit, i.e., $R_S = R_D$, in the following we assume $n = n_S = n_D$ where n_S and n_D are the charge concentrations in S and D , respectively. Figure 2 shows $P_{R_S-R_D}$ (dark lines) and P_{e-ph_D} (light lines) as a function of the carrier concentration n for different values of T_S . Differently from other 2DES [17, 18], in graphene the electron-phonon coupling constant $\Sigma \propto \sqrt{n}$. As a consequence, the power adsorbed by phonons increases monotonically with source temperature and carrier concentration both in the clean and dirty limit (see Fig. 2). Notably, P_{e-ph_D} is always of

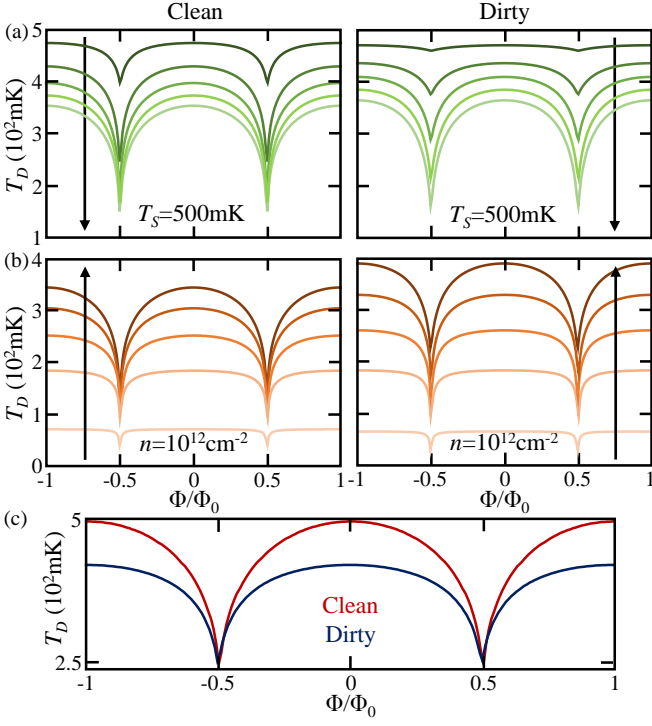


FIG. 3: (a) Drain temperature as a function of the magnetic flux Φ for $n = 1, 3, 5, 7, 10 \times 10^{11} \text{cm}^{-2}$ (rising in the arrow direction) at $T_S = 500 \text{ mK}$ in the limits of clean (left) and dirty graphene (right). (b) Drain temperature as a function of Φ for source temperatures ranging from 100 mK to 500 mK with step of 100 mK (as shown by the arrow) at $n = 1 \times 10^{12} \text{cm}^{-2}$ for clean (left) and dirty graphene (right). (c) Maximum achievable modulation of T_D for clean (red) and dirty (blue) graphene.

the order of fW for our system. In metals, the electron phonon coupling is typically stronger and thermal losses are larger. For instance, at $T = 200 \text{ mK}$ in our system $P_{e-phD} \leq 1 \text{ fW}$, while AlMn or Cu thin films of comparable dimensions show a dissipated power of $\sim 30 \text{ fW}$ [27] or $\sim 100 \text{ fW}$ [2], respectively. On the other side, the photonic transmitted power P_{RS-RD} lowers with n with a steeper rate at higher values of T_S [$\mathcal{T}(\omega) \propto 1/n^2$]. The difference in the transmitted power between the clean and dirty limit predominantly arises from the difference in mobilities considered in the two cases ($\mu_{clean} = 10^5 \text{ cm}^2/\text{Vs}$ and $\mu_{dirty} = 10^4 \text{ cm}^2/\text{Vs}$). At a fixed n , lower mobility implies larger values of impedance (resistance) of the reservoirs and, as a consequence, more effective power transfer between source and drain electrode [i.e. greater photonic transfer-function $\mathcal{T}(\omega)$].

Since $P_{RS-RD}(n)$ decreases for increasing n (see Fig. 2), $T_{MAX} \doteq T_D(\Phi = 0)$ decreases for increasing n as shown in Fig. 3-a in the case of $T_S = 500 \text{ mK}$. Since the heat current is not physically measurable, we evaluate the phase coherent modulation of thermal transport by monitoring T_D as a function of the magnetic flux. The temper-

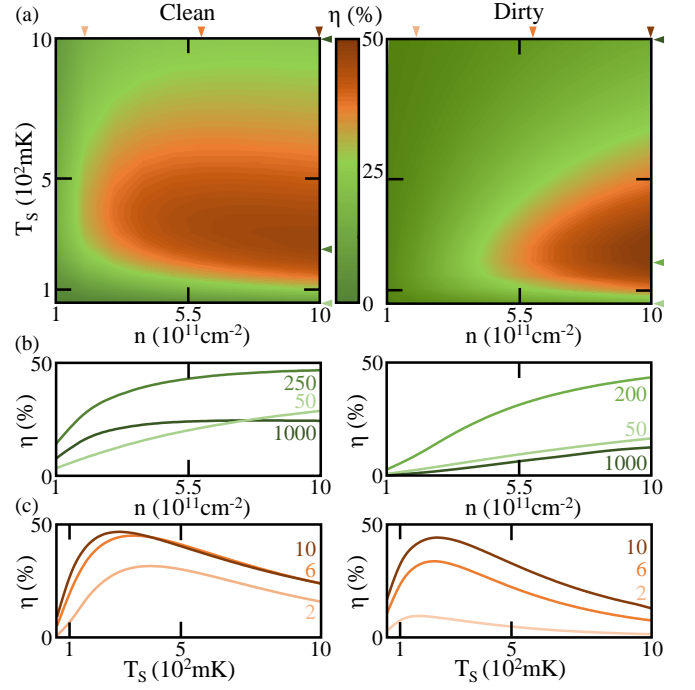


FIG. 4: (a) Contour plot of η as a function of n and T_S . (b) η vs n for different values of T_S (mK) indicated by the arrows in plot (a). (c) η vs T_S for different values of n (10^{12}cm^{-2}) shown by the arrows in plot (a). Left (right) panel is for clean (dirty) graphene.

ature modulation $\Delta T_D = T_D(\Phi = 0) - T_D(\Phi = \Phi_0/2)$ increases with the charge carrier concentration of the electrodes for a fixed value of the source temperature both in the clean and the dirty limits.

In Fig. 3-b we study T_D as a function of Φ for different source temperatures at $n = 1 \times 10^{12} \text{cm}^{-2}$. The modulation is quite small for low temperatures (see lowest line in Figure 3-a representing $T_S = 100 \text{ mK}$), because the electron-phonon coupling is small and $P_{e-phD} \leq P_{RS-RD}$ for most values of Φ . In the limit of clean graphene the maximum temperature modulation can be as large as $\Delta T_D \sim 245 \text{ mK}$ at $T_S = 950 \text{ mK}$ and $n = 8 \times 10^{11} \text{cm}^{-2}$, while in the dirty limit can be as large as $\Delta T_D \sim 164 \text{ mK}$ at $T_S = 550 \text{ mK}$ and $n = 1 \times 10^{12} \text{cm}^{-2}$ (see Fig. 3-c). The predicted temperature modulations are unprecedented even for galvanic heat transport in metallic systems [1, 2, 28].

In order to envision the thermal efficiency of the system we introduce two parameters: the transmittance $\tau = T_D(\Phi = 0)/T_S$ and the efficiency $\eta = (\Delta T_D/T_S) \times 100$. τ decreases for increasing temperature, because the electron-phonon coupling becomes stronger [see Eq. (4) and Eq. (5)]. In particular, $\tau_{MAX}(T_S = 50 \text{ mK}) \sim 0.99$ and $\tau_{MAX}(T_S = 1 \text{ K}) \sim 0.83$ in the clean limit, while $\tau_{MAX}(T_S = 50 \text{ mK}) \sim 0.99$ and $\tau_{MAX}(T_S = 1 \text{ K}) \sim 0.92$ in the dirty limit. The efficiency parameter is shown in the contour plots of Fig. 4-a as a function of n and T_S . The behavior of η is different in the case of clean

(left panel of Fig. 4-a) and dirty (right panel) graphene. In the first case, the efficiency of thermal conversion increases already for small n and maintains high values for a wide range of temperatures with a maximum for $n = 1 \times 10^{12} \text{cm}^{-2}$ at $T_S = 250$ mK. In the second case, η increases gradually till large carrier concentrations with a reduced high conversion area characterized by a maximum at $n = 1 \times 10^{12} \text{cm}^{-2}$ and $T_S = 200$ mK. Notably, in both cases the maximum value of η is $\sim 50\%$ and the system can work till high temperature (1K). This arises from the small values of the electron-phonon constant of graphene Σ in all the parameters space.

In order to discuss in detail the behavior of η with $P_{R_S-R_D}$ and P_{e-ph_D} , we show some curves at fixed values of T_S (Fig. 4-b) and n (Fig. 4-c). At constant source temperature the efficiency increases with the carrier concentration, because the electron-photon coupling decreases more steeply near $\Phi = \Phi_0/2$ than near $\Phi = 0$. In general, at high source temperature the device efficiency decreases, because the electron-phonon coupling is bigger. In the clean limit at high T_S , the difference between the maximum (at $\Phi = 0$) and minimum (at $\Phi = \Phi_0/2$) value of $P_{R_S-R_D}$ starts to decrease and P_{e-ph} rises. As a consequence, the efficiency decreases as shown by the curve at $T_S = 1$ K of the left panel of Fig. 4-b. The increase of electron-phonon coupling with temperature [Eq. (4) and (5)] is even more evident. In fact, all the curves in Fig. 4-c show a non-monotonic behavior of the energy conversion efficiency. In the case of clean graphene all the maxima move towards low temperature by increasing carrier concentration, while for dirty graphene they shift in the opposite direction. This difference stems from the T^4 dependence of $P_{e-ph_{clean}}$ [see Eq. (4)] and the T^3 of $P_{e-ph_{dirty}}$ [see Eq. (5)].

The system proposed in this work (see Fig. 1-b) is the simplest arrangement able to coherently manipulate the thermal transport exclusively through tunable electron-photon and electron-phonon couplings. Increase the number of *SQUIDS* in the coupling circuit would be the natural solution in order to improve the tunability of the electron-photon mediated thermal transport. On the other hand, it would complicate both the frequency-dependent transfer function and the experimental realization of the proposed device. Therefore, the choice of adding more *SQUIDS* needs to take in account the compromise between tunability and reliability.

Finally, we want to point out that the system we pro-

pose can be also used to experimentally determine the dependence of the electron-phonon coupling in 2D electronic system with the charge carrier concentration, the defects concentration and the temperature [17]. Within this approach the heat transferred to the sample under investigation can be controlled with unprecedented precision, thereby allowing to push the limit of the measurements to lower temperatures and higher accuracy.

IV. CONCLUSIONS

In summary, we have studied the impact of electron-photon and electron-phonon coupling in the coherent heat transport between two bodies in non galvanic contact within a simple circuitual approach. We have proposed a system consisting of a pair of gated 2DES capacitively-coupled through a dc-SQUID. This arrangement guarantees robustness on the device parameters of the performances and feasible nano-fabrication process. Furthermore, the architecture we propose ensures both high transmissivity and large modulation of thermal transport. In principle, the possibility to modulate the impedance of the source electrode could be used to control the temperature of another quantum device without interfering with its behavior (by matching and unmatching the input and output impedances). In order to determine the efficiency of the system, we have presented quantitative results for source and drain electrodes made of graphene in the clean and dirty limits. In both cases, the proposed system shows unprecedented thermal modulations (up to $\Delta T_{D_{MAX}} \sim 245$ mK), maximum transmittance $\tau_{MAX} \sim 0.99$ and energy conversion efficiencies reaching $\eta_{MAX} \sim 50\%$. The high modulation and control of thermal transport make this system the ideal platform for the investigation of electron-phonon coupling in 2D materials.

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